

5. O. H. W. Siegmund, M. Gummin, G. Gaines, G. Naletto, J. Stock, R. Raffanti, J. Hull, R. Abiad, T. Rodriguez-Bell, T. Magoncelli, P. Jelinsky, W. Donakowski, and K. Kromer, "Performance of the double delay line microchannel plate detectors for the Far Ultraviolet Spectroscopic Explorer," *Proc. SPIE* **3114**, pp. 283-294, 1997.
6. A. S. Tremsin, O. H. W. Siegmund, M. A. Gummin, P. N. Jelinsky, and J. M. Stock, "Electronic and optical moiré interference with microchannel plates: artifacts and benefits," *Appl. Opt.* **38**, 2240-2248, 1999.
7. O. H. W. Siegmund, J. Vallergera and B. Wargelin, "Background events in microchannel plates," *IEEE Trans. Nucl. Sci.*, **35**, 524-528, 1988.
8. R. G. Ohl, T. T. Saha, S. D. Friedman, R. H. Barkhouser and H. W. Moos, "Imaging performance of telescope mirrors for far-ultraviolet astronomy," *Appl. Opt.*, 2000, in press.
9. C. M. Oliveira, K. Retherford, S. J. Conard, R. H. Barkhouser, and S. D. Friedman, "Aging studies of LiF coated optics for use in the far ultraviolet," *Proc. SPIE*, **3765**, 52-60, 1999.
10. H. Herzig, A. R. Toft and C. M. Fleetwood, Jr. "Long-duration orbital effects on optical coating materials," *Appl. Opt.* **32**, 1798-1804, 1993.
11. J. F. Seely, G. E. Holland, W. R. Hunter, R. P. McCoy, K. F. Dymond and M. Corson, "Effect of oxygen bombardment on the reflectance of silicon carbide mirrors in the extreme ultraviolet region," *Appl. Opt.* **32**, 1805-1810, 1993.
12. J. F. Rose, C. Heller-Bowyer, M. A. Rose, M. Swam, W. Miller, G. A. Kriss and W. R. Oegerle, "OPUS: The FUSE Science Data Pipeline," *Proc. SPIE* **3349**, pp. 410-420, 1998.